IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: C. N. Kline

Group Art Unit:

: IBM Corporation

Examiner:

: Intellectual Property Law

Serial No.:

: Dept. IQOA/Bldg. 040-3

Filed: Herewith

1701 North Street

Title: SYSTEM, METHOD AND

Endicott, NY 13760

PROGRAM PRODUCT FOR MANAGING PRIVILEGE LEVELS IN A COMPUTER

SYSTEM

Assistant Commissioner For Patents

Washington, D.C. 20231

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

It is respectfully requested that the publications identified on the enclosed PTO-1449 Form(s) be considered by the United States Patent and Trademark Office (USPTO) in the subject United States patent application and be made of record herein.

Respectfully submitted,

Dated: Mad 1, 2004
Telephone: 607-429-4368

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607-429-4119

Arthur J. Samodovitz

Req. No. 31,297

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)	Application Number		
END920030127US1			
Applicant(s) C. N. Kline			
Filing Date	Group Art Unit		

				Herew		roup Art Unit			
				U.S. PATENT DOCUMENTS					
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS		G DATE OPRIATE	
		US 2002/0026591 A1	2/28/02	B. V. Hartley et al	713	201	04/12/01		
		US 2002/0095591 A1	7/18/02	W. T. anielle t al	713	200	01/12/01 12/17/01 10/28/97		
		US 2003/0115446 A1	06/19/03	K. D. Simon et al	713	100			
		6,014,666	01/11/00	P. J. Helland et al	707	9			
		6,185,689	02/06/01	R. F. Todd et al	713	201	6/24/98	6/24/98	
		6,233,576	05/15/01	J. R. Lewis	707	9	09/25/95		
	•								
				FOREIGN PATENT DOCUMEN	NTS	_			
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation		
			<u> </u>				YES	NO	
				OTHER DOCUMENTS (Inclu	iding Author, Title, D	ate, Pertinent Po	ages, Etc.)		
		ION Secure TM 3500	G2-SIE, ION Ne	towrks, Inc., Piscataway, NJ 200					
		MQSeries Planning C	Guide, IBM Corp.	1999					
		Candle Corp's MQSe	cure, EAI Journ	al, Jun 2002, http://www.bijonlin	e.com/PDF/FIMQS	Secure.pdf.		19.3	
EXAMINE	R			DATE CONSIDERED)				

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.